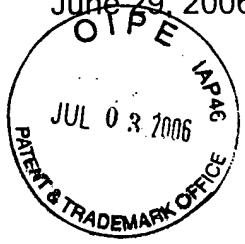


*JFW*

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patent attorneys  
June 29, 2006



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*Laura J. Pleasants*

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Date of Signature: June 29, 2006

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TECHNICAL SPECIALIST  
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Re: U.S. Patent Application Serial No. 10/615,842 for  
DEPOSITION METHOD FOR NANOSTRUCTURE  
MATERIALS  
Our Ref. No. 421/170/8/2 CIP

Sir:

Please find enclosed in connection with the subject U.S. patent application the following documents:

1. Information Disclosure Statement (2 pages);
2. Form PTO-1449 (2 pages) in duplicate;
3. Copies of cited references (20 references); and
4. A return-receipt postcard to be returned to us with the U.S. Patent and Trademark Office filing stamp thereon.

A check in the amount of \$180.00 is enclosed for the fee due. The Commissioner is authorized to charge any deficiencies of payment associated with the filing of this correspondence to Deposit Account No. 50-0426 to avoid the unintentional abandonment of the instant application.

Respectfully submitted,

JENKINS, WILSON, TAYLOR & HUNT, P.A.

*Jeffrey L. Wilson*

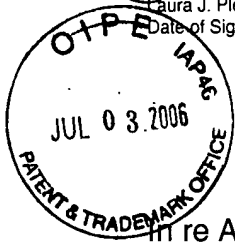
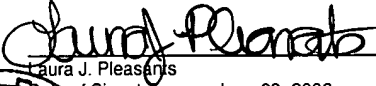
Jeffrey L. Wilson  
Registration No. 36,058  
Customer No: 25297

Enclosures

*5*

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PATENT

   
\_\_\_\_\_  
Laura J. Pleasant  
Date of Signature June 29, 2006  
\_\_\_\_\_  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
In re Application of: Oh et al.

Group Art Unit: 1753

**Serial No.: 10/615,842**

Examiner: Phasge, Arun S.

Filed: July 10, 2003

Docket No.: 421/170/8/2 CIP

Confirmation No.: 9995

For: DEPOSITION METHOD FOR NANOSTRUCTURE MATERIALS

\*\*\*\*\*

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. 1.56, 1.97, and 1.98, applicants' undersigned attorney brings to the attention of the Patent and Trademark Office the documents listed on the attached Form PTO-1449. Copies of the references as well as Form PTO-1449 are attached hereto. This is not to be construed as a representation that a search has been made or that a reference is relevant merely because cited.

07/06/2006 SSESHE1 00000034 10615842

01 FC:1806

180.00 OP

Serial No.: 10/615,842

This information is being submitted subsequent to the later of three months after the filing date of the present application or the mailing of the first Office Action on the merits, but before the mailing of a Final Action or the Notice of Allowance.

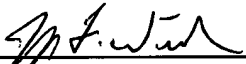
Early passage of the subject application to issue is earnestly solicited.

A check in the amount of \$180.00 is enclosed for the fee due. The Commissioner is authorized to charge any deficiencies of payment associated with the filing of this correspondence to Deposit Account No. 50-0426 to avoid the unintentional abandonment of the instant application.

Respectfully submitted,

JENKINS, WILSON, TAYLOR & HUNT, P.A.

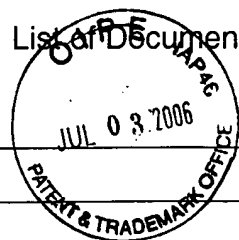
Date: 6-29-06

By:   
Jeffrey L. Wilson  
Registration No. 36,058  
Customer No: 25297

Enclosures

**FORM PTO-1449 U.S. Department of Commerce**  
**Patent and Trademark Office**

List of Documents Cited by Applicant



Application No.:	10/615,842
Filing Date:	July 10, 2003
First Named Inventor:	Oh et al.
Group:	1753
Examiner:	Phasge, Arun S.
Attorney Docket No.:	421/170/8/2 CIP

**U.S. PATENT DOCUMENTS**

Examiner Initial	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where relevant passages or relevant figures appear
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	2.	5,906,721	05/25/1999	Bojkov et al.	
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	16.	2004/0108298	06/10/2004	Gao	
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## FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number (country code, no., kind code (if known))	Publication Date	Name of Patentee or Applicant	Pages, columns, lines where relevant passages appear	T
	1.	2002301700 JP	10/15/2002			
	2.	2003075372 WO	09/12/2003			

## OTHER DOCUMENTS

Examiner Initials	Cite No.	Include Author (in CAPITAL LETTERS), Title, Journal, Date, Pertinent Pages, Etc.	T

EXAMINER \_\_\_\_\_ DATE CONSIDERED \_\_\_\_\_

\*Examiner Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.